

**Cold RF Plasma Treatment Modifies Wettability and Germination Speed of Plant Seeds (Ariel)**

Edward Bormashenko, Physics

Elyashiv Drori

A novel method for modifying the wettability and germination properties of a diversity of seeds by cold radiofrequency air plasma treatment. The suggested method, air plasma treatment, leads to a dramatic decrease in the apparent contact angle, increase in water absorption, control speed of germination and yield (control of germination rate).

**Contact for more information:**

Zvi Cheshnover , Director of Business Development for Engineering & Natural Sciences,  
+972-54-556-1072

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